



MTS-2700US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yuji Judai : Art Unit: 2814
Serial No.: November 21, 2001 : Examiner:
Filed: 09/990,474 :
FOR: SEMICONDUCTOR DEVICE HAVING A :
FERROELECTRIC CAPACITOR WITH TENSILE :
STRESS PROPERTIES (AS AMENDED) :

PATENT

#5B JHC Annot

M. Barton
2/5/03

TECHNOLOGY CENTER 2800

DEC 11 2002

RECEIVED

**SUPPLEMENTAL
PRELIMINARY AMENDMENT**

Assistant Commissioner for Patents
Washington, D.C. 20231

S I R :

Prior to examination, please amend the above-identified application as follows:

IN THE TITLE:

Please delete the title in its entirety and substitute therefore:

31

A METHOD FOR FORMING A SEMICONDUCTOR DEVICE

Respectfully submitted,

Ratner-Presha

Alan Ratner, Reg. No. 19,717
Attorney for Applicant

AR/mjc

Dated: December 4, 2002

Suite 301, One Westlakes, Berwyn
P.O. Box 980
Valley Forge, PA 19482-0980
(610) 407-0700

BEST AVAILABLE COPY

The Assistant Commissioner for Patents is hereby authorized to charge payment to Deposit Account No. 18-0350 of any fees associated with this communication.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, with sufficient postage, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on:

12/4/02